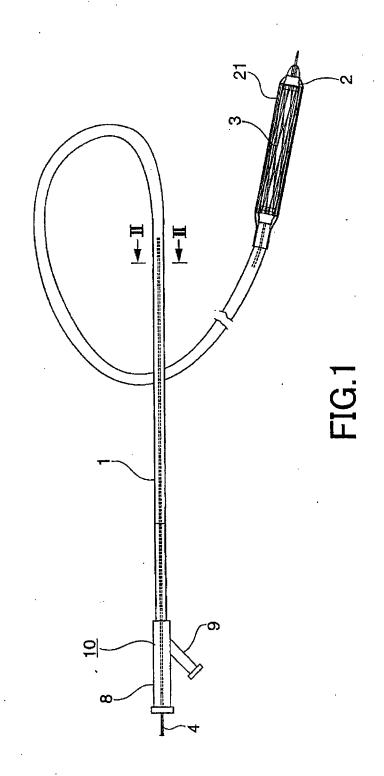
[図1]



[図2]

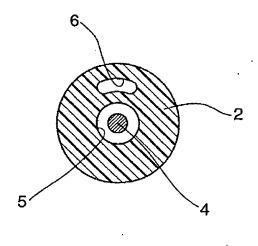
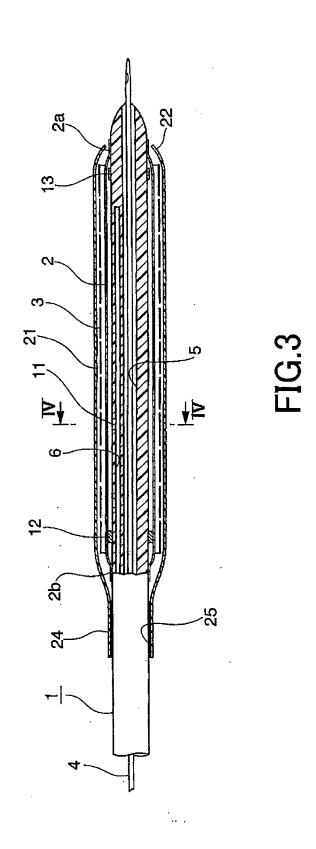


FIG.2

[図3]



[図4]

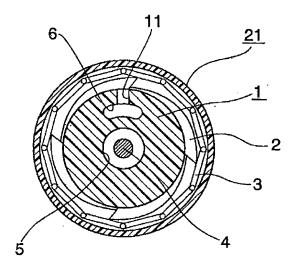


FIG.4

[図5]

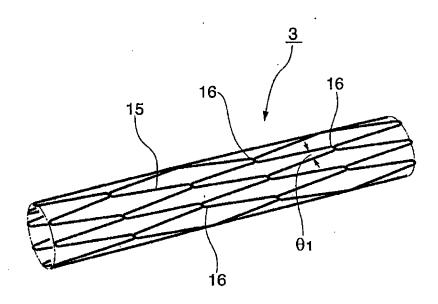


FIG.5

[図6]

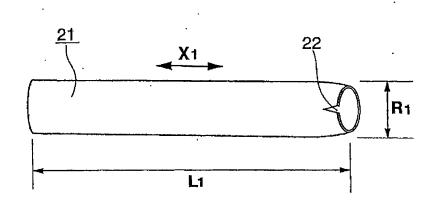
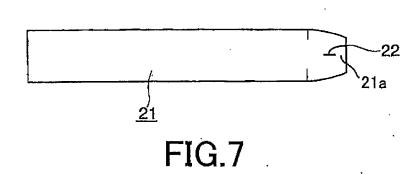


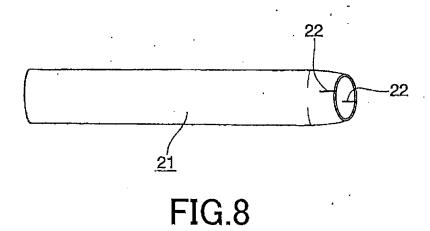
FIG.6

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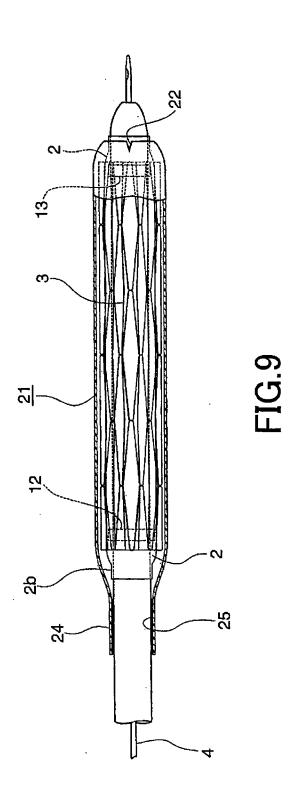
[図7]



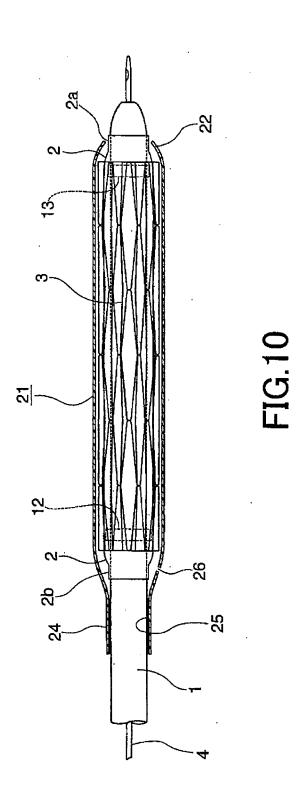
[図8]



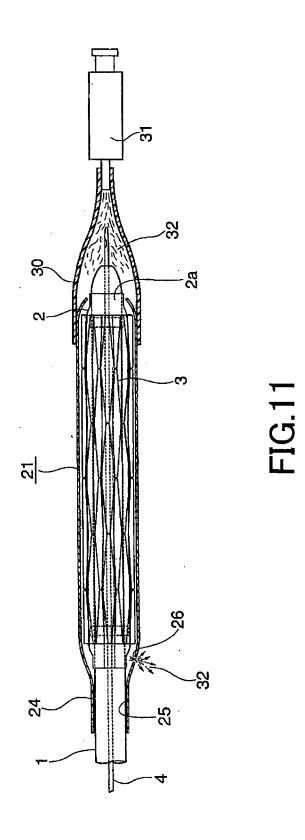
[図9]



[図10]



[図11]



[図12]

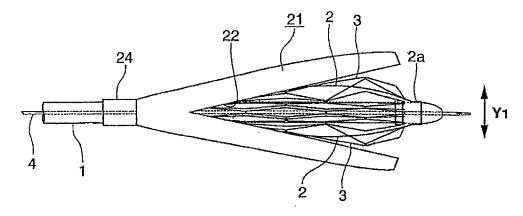


FIG.12

[図13]

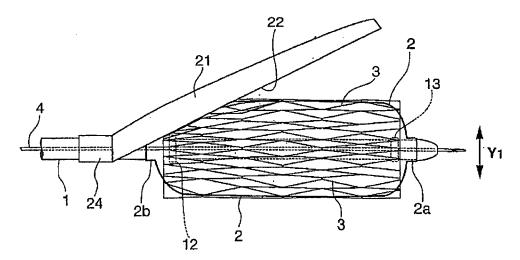


FIG.13

[図14]

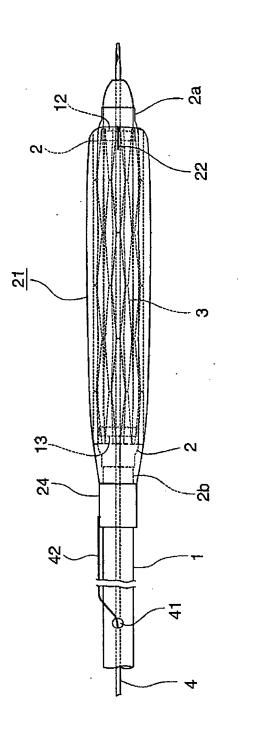
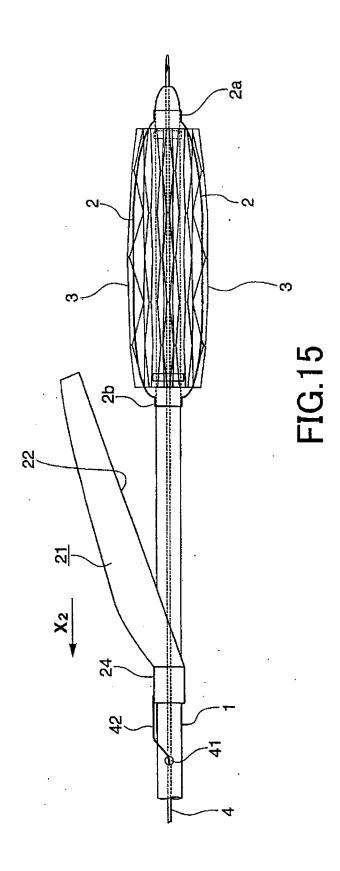


FIG. 14

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[図15]



[図16]

